

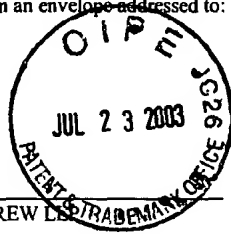
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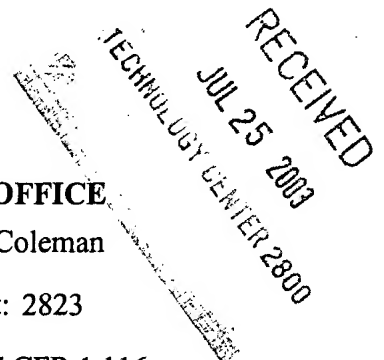
7/21/03
TOWNSEND and TOWNSEND and CREW LLP

By:



AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE -
EXAMINING GROUP 2823

PATENT
Attorney Docket No.: A5771/T042200



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

ZHENGQUAN TAN et al.

Application No.: 09/854,083

Filed: May 11, 2001

For: HDP-CVD DEPOSITION
PROCESS FOR FILLING HIGH
ASPECT RATIO GAPS

Examiner: William D. Coleman

Technology Center/Art Unit: 2823

AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE EXAMINING
GROUP 2823

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Sir:

In response to the Final Office Action mailed May 21, 2003 on the above-referenced application, and for the purpose of putting the application in condition for allowance, please consider the following comments.

Remarks/Arguments begin on page 2 of this paper.